



Docket No.: 50090-334

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PATENT

9-12-04

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EOT (2)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of : Customer No. 20277  
Masanobu IWASAKI, et al. : Confirmation No.  
Serial No.: 09/934,474 : Group Art Unit: 3723  
Filed: August 23, 2001 : Examiner: H. Shakeri

For: POLISHING SOLUTION SUPPLY SYSTEM, METHOD OF SUPPLYING  
POLISHING SOLUTION, APPARATUS FOR AND METHOD OF POLISHING  
SEMICONDUCTOR SUBSTRATE AND METHOD OF MANUFACTURING  
SEMICONDUCTOR DEVICE

**RESPONSE TO ORDER RETURNING UNDOCKETED APPEAL TO  
EXAMINER**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

02/12/2004 ECOLBERT 00000005 500417 09934474  
01 FC-9252 410.00 DA

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TECHNOLOGY CENTER R370

**REMARKS**

In the Order Returning Undocketed Appeal to Examiner mailed May 20, 2003, the Administrator Han asserted that the Notice of Appeal was filed on September 4, 2002, which exceeded three months from the date of the April 18, 2002 final Office Action. Administrator Han then suggested the case should have been abandoned. Appellants disagree.

As apparent from the PAIR file contents history, the Request for Extension of Time was granted after the Notice of Appeal was filed with a two-month extension. Accordingly, the case should **not** be abandoned as asserted by Administrator Han. For the

09/934,474

Administrator's convenience, a copy of the PAIR file and of a date-stamped card indicating the filing of a Notice of Appeal, request for a two-month extension and payment therefor are enclosed herewith.

Accordingly, the Administrator is requested to clarify the record by indicating that this application is not abandoned.

To the extent necessary, a petition for an extension of time under 37 C.F.R. 1.136 is hereby made. Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit account.

Respectfully submitted,

MCDERMOTT, WILL & EMERY



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Registration No. 26,106

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**Date: November 17, 2003**  
Facsimile: (202) 756-8087

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Applicant:

Masanobu IWASAKI et al.

Docket No.

50090-334

POLISHING SOLUTION SUPPLY SYSTEM, METHOD OF  
SUPPLYING POLISHING SOLUTION, APPARATUS FOR AND  
METHOD OF POLISHING SEMICONDUCTOR SUBSTRATE AND

METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE

Serial/Reg./Patent No. 09/934,474

Title:

Date Sent:

9/4/2002

Transmittal Letter

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New Patent App  Utility  Design  Cont.  CIP  Div.

PCT  CPA  RCE  Prov

Other: \_\_\_\_\_

\_\_\_\_\_ pages of Specification

\_\_\_\_\_ pages of Claims

\_\_\_\_\_ pages of Abstract

\_\_\_\_\_ pages of Formal/Informal Drawings

Small Entity  Large Entity

Declaration/Power of Attorney

Recordation of Assignment/Security Agreement

Information Disclosure Statement

Form PTO 1449

\_\_\_\_\_ copies of cited references

Preliminary Amendment

Response to Missing Parts Notice

Resp. to Notice to Correct App. Papers

Certified Copy of Priority Doc.

Claim for Convention Priority

Response/Amendment to Office Action of

Request for 2 month Extension of Time

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THE PATENT AND TRADEMARK OFFICE DATE STAMPED HEREON IS ACKNOWLEDGEMENT THAT THE ITEMS CHECKED ABOVE, WERE RECEIVED BY THE PTO ON THE DATE STAMPED.



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**PATENT APPLICATION INFORMATION RETRIEVAL****PAIR****FAQ****Help****Feedback****Other Links**[E-Business Center Patents](#)[Employee Locator](#)[Class/Subclass GAV Information](#)[Information Contacts](#)**Search results for application number:09/934,474**

<b>Application Number:</b>	09/934,474	<b>Customer Number:</b>	-
<b>Filing or 371(c) Date:</b>	08-23-2001	<b>Status:</b>	Reply Brief Noted Examiner
<b>Application Type:</b>	Utility	<b>Status Date:</b>	03-17-2003
<b>Examiner Name:</b>	SHAKERI, HADI	<b>Location:</b>	TC 3700 CENTRAL CP2-10C25
<b>Group Art Unit:</b>	3723	<b>Location Date:</b>	10-20-2003
<b>Confirmation Number:</b>	8431	<b>Earliest Publication No:</b>	US 2002-0065022 A
<b>Attorney Docket Number:</b>	50090-334	<b>Earliest Publication Date:</b>	05-30-2002
<b>Class/ Sub-Class:</b>	451/041	<b>Patent Number:</b>	-
<b>First Named Inventor:</b>	Masanobu Iwasaki, Tokyo, (JP)	<b>Issue Date of Patent:</b>	-
<b>Title Of Invention:</b>	Polishing solution supply system, method of supplying polishing solution, apparatus for and method of polishing semiconductor substrate and method of manufacturing semiconductor device		

**Continuity Data****Published Documents****File Contents History**

Number	Date	Contents Description
32	10-02-2003	Appeal Awaiting BPAI Docketing
31	05-20-2003	Order Returning Undocketed Appeal to the Examiner
30	04-22-2003	Appeal Awaiting BPAI Docketing
29	03-18-2003	Mail Reply Brief Noted by Examiner
28	03-17-2003	Reply Brief Noted by Examiner
27	01-27-2003	Date Forwarded to Examiner
26	01-22-2003	Reply Brief Filed
25	11-22-2002	Mail Examiner's Answer
24	11-21-2002	Examiner's Answer to Appeal Brief
23	11-14-2002	Date Forwarded to Examiner
22	11-04-2002	Appeal Brief Filed
21	09-04-2002	Notice of Appeal Filed
20	09-04-2002	Request for Extension of Time - Granted
19	07-26-2002	Mail Advisory Action (PTOL - 303)
18	07-26-2002	Advisory Action (PTOL-303)
17	07-25-2002	Date Forwarded to Examiner

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16	07-18-2002	Amendment after Final Rejection
15	04-18-2002	Mail Final Rejection (PTOL - 326)
14	04-16-2002	Final Rejection
13	03-13-2002	Date Forwarded to Examiner
12	03-04-2002	Response after Non-Final Action
11	12-04-2001	Mail Non-Final Rejection
10	11-28-2001	Non-Final Rejection
9	08-23-2001	Request for Foreign Priority (Priority Papers May Be Included)
8	08-23-2001	Information Disclosure Statement (IDS) Filed
7	10-29-2001	Case Docketed to Examiner in GAU
6	10-01-2001	Application Dispatched from OIPE
5	09-28-2001	Correspondence Address Change
4	09-28-2001	Correspondence Address Change
3	09-27-2001	Correspondence Address Change
2	08-29-2001	IFW Scan & PACR Auto Security Review
1	08-23-2001	Initial Exam Team nn

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